Electronic Acknowledgement Receipt				
EFS ID:	2970517			
Application Number:	10689617			
International Application Number:				
Confirmation Number:	4799			
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device			
First Named Inventor/Applicant Name:	Satoru Okamoto			
Customer Number:	26171			
Filer:	Diana DiBerardino/Arlene Yates			
Filer Authorized By:	Diana DiBerardino			
Attorney Docket Number:	12732-170001			
Receipt Date:	10-MAR-2008			
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Application Type:	Utility under 35 USC 111(a)			

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$810
RAM confirmation Number	8235
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Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
Request for Continued Examination (RCE)	Request for Continued Examination	10700170001005 15	88868		
	12732170001RCE.pdf	e51c63ff22a7e7f6bd717a8fc543b89c5 6afefd3	no	1	
Warnings:					
This is not a U	SPTO supplied RCE SB30 form.				
Information:					
2 Informa	Information Disclosure Statement	12732170001IDS.pdf	209664	no	2
2	(IDS) Filed		ac6a7d75fc2eee5cbe8c375c1c1e71f51 eb80c68		
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Information:					
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3 Foreign	Foreign Reference	12732170001full.pdf	1634915	no	25
	Foreign Reference		c3f8c548cfcc255e8ae4edb4b92cff74ae 4e27be		
Warnings:					
Information:					
4 Fee Worksheet (PTC	Fee Worksheet (PTO-06)	fee-info.pdf	8220	no	2
	r ee worksneet (r 10-00)	ree-imo.pai	1d152174be460111173d62fd4f2c37ae a3fe412c		
Warnings:					
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		Total Files Size (in bytes):	196	41667	

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.